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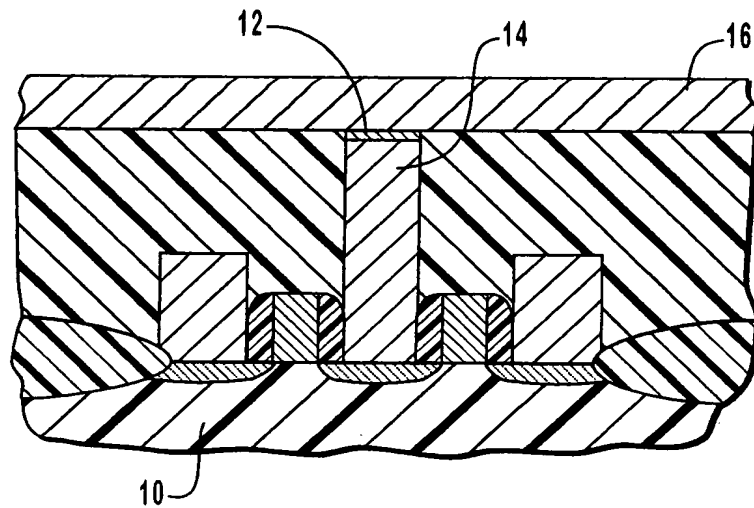


FIG. 1

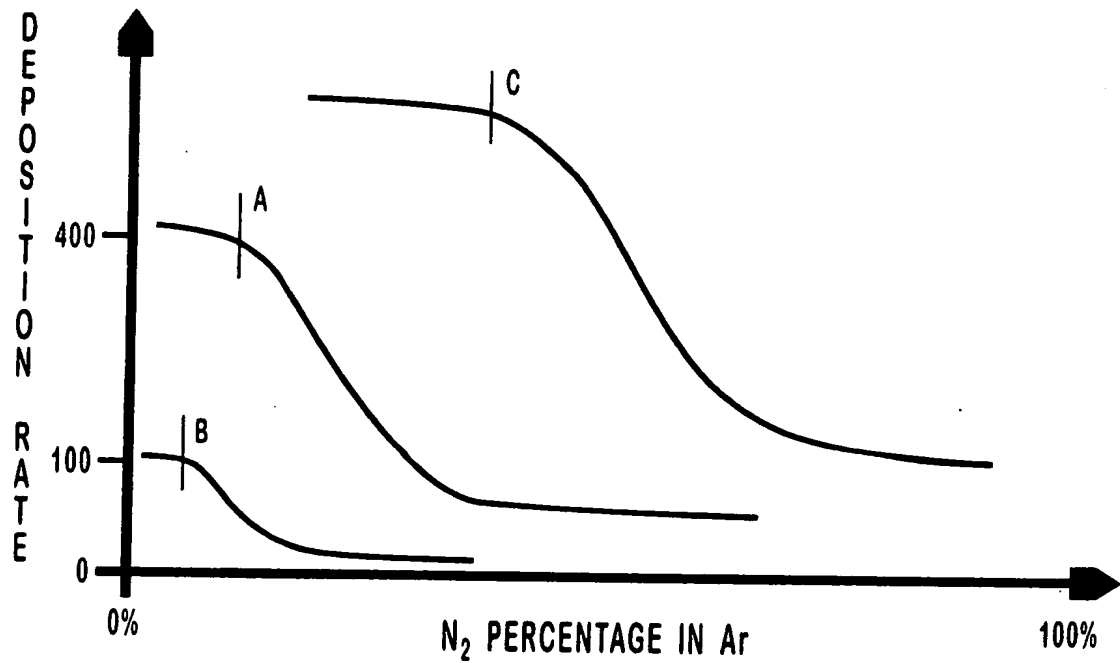


FIG. 2

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Title: Process for Forming a Difusion Barrier
Material Nitride Film
Inventor: Yongjun Hu
Docket No.: 11675.73.1.2.1

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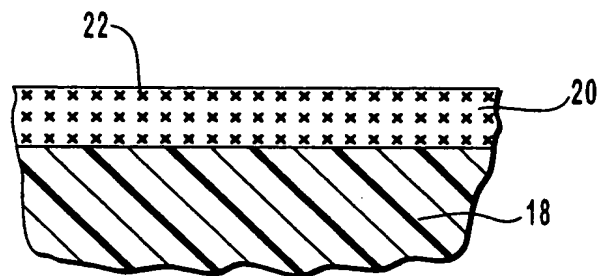


FIG. 3

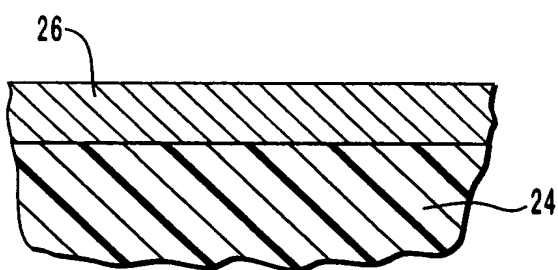


FIG. 4

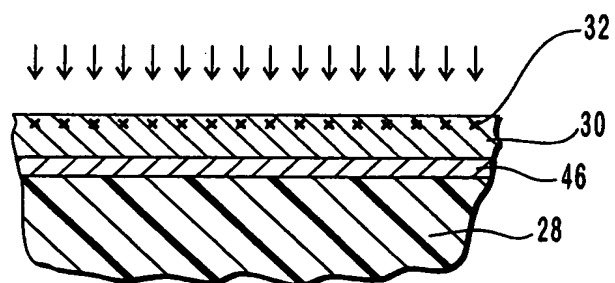


FIG. 5

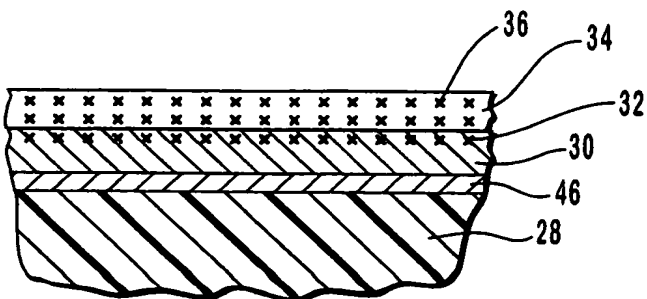


FIG. 6

Title: Process for Forming a Difusion Barrier
Material Nitride Film
Inventor: Yongjun Hu
Docket No.: 11675.73.1.2.1

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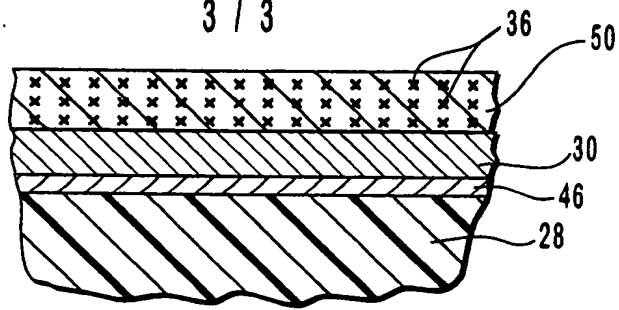


FIG. 7

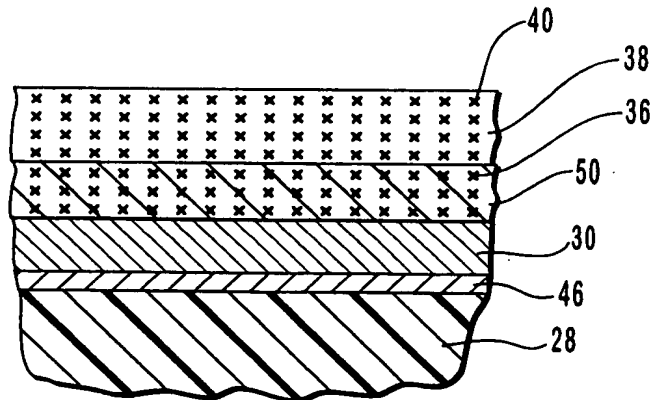


FIG. 8

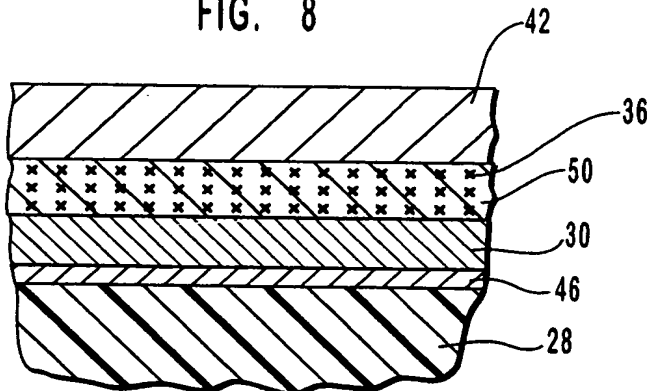


FIG. 9

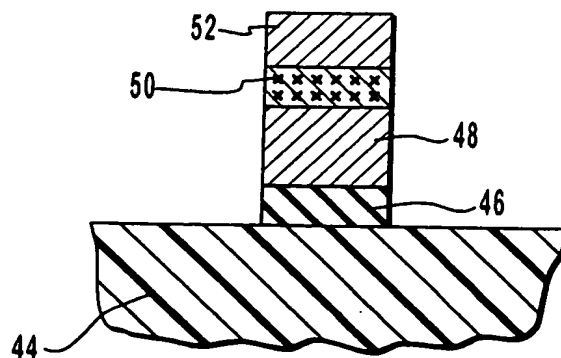


FIG. 10

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